Notice of References Cited Application/Control No. 10/685,674 Examiner John Juba, Jr. Applicant(s)/Patent Under Reexamination KANEKO, SHINJI Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-6,665,109	12-2003	Little et al.	359/290
	В	US-6,581,465	06-2003	Waters et al.	73/514.26
	С	US-6,568,647	05-2003	Graves et al.	248/476
	D	US-6,525,880	02-2003	Flanders et al.	359/578
	E	US-6,464,364	10-2002	Graves et al.	359/846
	F	US-6,424,450	07-2002	Goossen, Keith W.	359/290
	G	US-5,561,523	10-1996	·Blomberg et al.	356/454
	Н	US-4,093,351	06-1978	Perkins et al.	359/847
	1	US-			
	J	ÙS-			
	к	US-		·	
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р	•				
	Q					
	R	,				·
	S					
	I					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
	U	Gleb Vdovin, et al., "Technology and applications oof micromachined silicon adaptive mirrors", Optical Engineering Vol. 36, no. 5, pp. 1382-1390, May 1997.				
	V					
	w					
	х					

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.